Docket No. 0756-2332

Art Unit: 2825

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re PATENT application of:

Takeshi FUKADA et al.)

Serial No. 09/904,906) Examiner: Unassigned

Filed: 07/16/2001)

For: GLASS SUBSTRATE ASSEMBLY, SEMICONDUCTOR)

DEVICE AND METHOD OF HEAT-TREATING GLASS SUBSTRATE

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 4/12/2002.

NOTICE OF RELATED APPLICATION

Commissioner for Patents and Trademarks

Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The Examiner's attention is directed to related U.S. Application Serial No. 09/983,882 filed on October 26, 2001.

The Commissioner is hereby authorized to charge fees under 37 \$\frac{1}{2}\$.F.R. \$\frac{1}{2}\$1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account to 2380.

Respectfully submitted,

Eric J. Robinson Reg. No. 38,285

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